OCI 31 2007 E UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Tadashi WATANABE et al. Group Art Unit: 2818

Application Number: 10/823,729 Examiner: David Vu

Filed: April 14, 2004 Confirmation Number: 5344

For: SEMICONDUCTOR DEVICE FABRICATION METHOD

Attorney Docket Number: 042341

Customer Number: 38834

AMENDMENT UNDER 37 C.F.R. § 1.114

MAILSTOP: RCE October 31, 2007

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

This paper is filed in response to the Office Action dated July 11, 2007. The response date having been extended by one month to November 11, 2007 by the Petition for Extension of Time filed herewith.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 14 of this paper.